



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)	PATENT APPLICATION
Inventors: Douglas J. Tweet, et al.)	
Serial No.: 10/807,931)	Attorney Docket No. SLA0586
Filed: March 23, 2004)	Group No. 2812
Title: METHOD TO FORM LOCAL SILICON-ON-NOTHING OR SILICON-ON-INSULATOR WAFERS WITH TENSIL- STRAINED SILICON)	Examiner: W. L. Lindsay, Jr. Confirmation No. 5155

Commissioner for Patents
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Sir:

**ASSOCIATE POWER OF ATTORNEY
CHANGE OF CORRESPONDENCE ADDRESS**

I hereby appoint Robert D. Varitz of 4915 S.E. 33rd Place, Portland, Oregon 97202, U. S. Patent and Trademark Office Registration Number 31436, as an associate attorney for the above-captioned matter, with full power of substitution and revocation, to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith.

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Date: 9/20/05

Respectfully submitted, ~

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